

Notice of References Cited	Application/Control No. 10/708,297	Applicant(s)/Patent Under Reexamination CHEN, PO-LUN	
	Examiner Richard H. Kim	Art Unit 2871	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,949,505	09-1999	Funamoto et al.	349/65
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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